

TFW



Attorney's Docket No.: 12406-059US2 / 1998P1821 US2 N

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Volker Haerle

Art Unit : 2824

Serial No. : 10/625,118

Examiner : Beth E. Owens

Filed : July 22, 2003

Title : METHOD OF PRODUCTION OF SEMICONDUCTOR COMPONENTS

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449.

This statement is being filed after a first Office action on the merits, but before receipt of a final Office action or a Notice of Allowance. I, the undersigned, hereby certify that each item of information contained in this statement was cited in a communication from a foreign patent office in a counterpart foreign application, the communication being dated March 19, 2004, which is not more than three months prior to the filing of this statement.

No fee is believed to be due. If, however, there are any charges or credits, please apply them to Deposit Account No. 06-1050.

Respectfully submitted,

Date: June 2, 2004

Jennifer A. Zanoocco
Reg. No. 54,563

Fish & Richardson P.C.
500 Arguello Street, Suite 500
Redwood City, California 94063
Telephone: (650) 839-5070
Facsimile: (650) 839-5071
50218664.doc

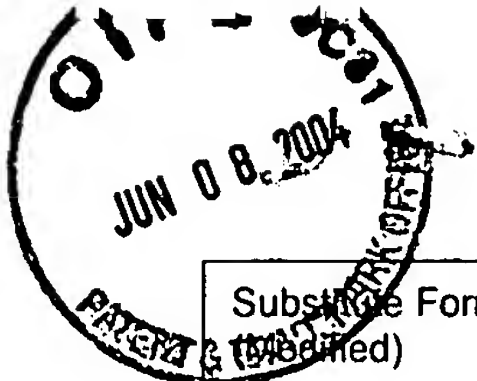
CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date of Deposit June 2, 2004

Signature Carlos A. Brunsil

Typed or Printed Name of Person Signing Certificate Carlos A. Brunsil



| | | | |
|---|--|--|--------------------------------------|
| Substitute Form PTO-1449 (Prescribed) Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b)) | U.S. Department of Commerce Patent and Trademark Office | Attorney's Docket No. 12406-059US2 | Application No. 10/625,118 |
| | Applicant Volker Haerle | | |
| | Filing Date July 22, 2003 | Group Art Unit 2824 | |

| U.S. Patent Documents | | | | | | | |
|-----------------------|-----------|-----------------|------------------|----------|-------|----------|----------------------------|
| Examiner Initial | Desig. ID | Document Number | Publication Date | Patentee | Class | Subclass | Filing Date If Appropriate |
| | AA | | | | | | |
| | AB | | | | | | |
| | AC | | | | | | |
| | AD | | | | | | |
| | AE | | | | | | |
| | AF | | | | | | |
| | AG | | | | | | |
| | AH | | | | | | |
| | AI | | | | | | |
| | AJ | | | | | | |
| | AK | | | | | | |

| Foreign Patent Documents or Published Foreign Patent Applications | | | | | | | | |
|---|-----------|-----------------|------------------|--------------------------|-------|----------|-------------|----|
| Examiner Initial | Desig. ID | Document Number | Publication Date | Country or Patent Office | Class | Subclass | Translation | |
| | | | | | | | Yes | No |
| | AL | JP 5006880 | 01/1993 | JP | | | Abstract | |
| | AM | JP 5160085 | 06/1993 | JP | | | Abstract | |
| | AN | JP 6224153 | 05/1994 | JP | | | Abstract | |
| | AO | | | | | | | |
| | AP | | | | | | | |

| Other Documents (include Author, Title, Date, and Place of Publication) | | |
|---|-----------|----------|
| Examiner Initial | Desig. ID | Document |
| | AQ | |
| | AR | |
| | AS | |
| | AT | |

| | |
|--|------------------------|
| Examiner Signature | Date Considered |
| EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. | |